

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

9/3/03 ±1/2/Amd+

Group Art Unit: 1756 Examiner: Kathleen Duda

In Re PATENT APPLICATION Of:		RECE!
Applicant	: Minoru WATANABE	} JUL 1500
Appin. No.	: 10/025,783	RECEIVED JUL 15 2003 TC 1700
Filed	: December 26, 2001))) AMENDMENT
For	: METHOD AND APPARATUS FOR FORMING RESIST PATTERN)
Attorney Ref.	: MAE 223 C1))

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This Amendment is submitted with the Applicant's Request for Continued Examination pursuant to 37 C.F.R. §1.114(a). Please amend the above-referenced application as follows:

IN THE CLAIMS

Please cancel claims 8-9, 12, 21-22 and 25 without prejudice or disclaimer to the subject matter recited therein. Please amend claims 1, 10-11, 13, 17, 23-24, 26 and 31-32, and add new claims 33-38, as shown in the listing of claims beginning on the next page under the heading Amendments to the Claims.